

L Number	Hits	Search Text	DB	Time stamp
1	55989	particle\$ near5 (detect\$4 or measur\$4 or count\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:26
2	126138	substrate and chamber	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:28
3	65443	lasers	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:28
4	292	(particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and (substrate and chamber) and lasers	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:29
5	135363	semiconductor near5 process\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:30
6	74504	lithograph\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:30
7	51	((particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and (substrate and chamber) and lasers) and (semiconductor near5 process\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:30
8	83	((particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and (substrate and chamber) and lasers) and lithograph\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:31
9	106	((particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and (substrate and chamber) and lasers) and (semiconductor near5 process\$4)) or (((particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and (substrate and chamber) and lasers) and lithograph\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:41
10	1484	(particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and lasers	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:42
11	74147	356/\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:42
12	136595	438/\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:43
13	3049	(particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and 356/\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:43
14	465	((particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and lasers) and 356/\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:43
15	42	((particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and lasers) and 438/\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:43
16	499	((particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and lasers) and 356/\$.ccls.) or (((particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and lasers) and 438/\$.ccls.)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 16:44

17	471	(((((particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and lasers) and 356/\$.ccls.) or (((particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and lasers) and 438/\$.ccls.) not (((particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and (substrate and chamber) and lasers) and (semiconductor near5 process\$4)) or (((particle\$ near5 (detect\$4 or measur\$4 or count\$4)) and (substrate and chamber) and lasers) and lithograph\$4))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 17:01
18	0	6456375.URPN.	USPAT	2003/04/09 16:47
19	38	("3713743" "3880526" "4152070" "4193692" "4198161" "4263511" "4497577" "4999514" "5012119" "5025169" "5140168" "5291626" "5331177" "5408307" "5444531" "5446531" "5485013" "5489977" "5565984" "5589935" "5596408" "5603233" "5604590" "RE35566" "5729025" "5757481" "5793485" "5800628" "5828458" "5872361" "5881578" "5889192" "5906802" "5923433" "5957144" "6007640" "6052184" "6141097").PN.	USPAT	2003/04/09 16:47
20	4	5121988.pn. 4739177.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/09 17:02
21	13	5121988.URPN.	USPAT	2003/04/09 17:02
22	3	("3548655" "3851169" "4739177").PN.	USPAT	2003/04/09 17:03
23	13	4739177.URPN.	USPAT	2003/04/09 17:03
24	9	("3431424" "3578867" "3622796" "3704951" "3772525" "3994603" "4221485" "4299489" "4473296").PN.	USPAT	2003/04/09 17:04